

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masanobu SATO et al.

Serial No.: 10/767,756

Filed: January 28, 2004

Confirmation No.: 5571

Date: March 8, 2007

Group Art Unit: 2813

Examiner: Unassigned

For: SUBSTRATE TREATMENT METHOD AND SUBSTRATE TREATMENT
APPARATUS

VIA EFS-WEB

Commissioner for Patents

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Alexandria, VA 22313-1450

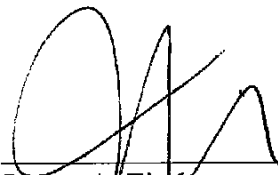
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Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

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Respectfully submitted,



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| APPLICANT'S ART CITATION (Use several sheets if necessary) | | Application 10/767,756 | | OFGS File No. P/2699-32 | |
| | | Applicant Masanobu SATO et al. | | | |
| | | Filing Date January 28, 2004 | | Group Art Unit 2813 | |

| U.S. PATENT DOCUMENTS | | | | | | |
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| Examiner Initial | Document Number | Date MM-YYYY | Name | Class | Sub-class | Filing Date If Appropriate |
| | US- | | | | | |
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| | | | | | | Yes | No |
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| | | Written Opposition issued December 12, 2006 in connection with the Korean Patent Application No. 10-2004-0011748 (Patent No. 602894) |
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| Examiner | Date Considered |
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